

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MIKI OGAWA, ET AL.) : Examiner: D. N. Deo
Application No.: 10/535,452) : Group Art Unit: 1765
Filed: May 19, 2005) : Confirmation No.: 7240
For: COLUMNAR STRUCTURED) : August 13, 2007
MATERIAL AND METHOD OF :
MANUFACTURING THE SAME)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT
AND PRELIMINARY AMENDMENT

Sir:

In response to the Office Action dated July 11, 2007, and prior to examination on the merits, the Examiner is respectfully requested to amend the above-identified application as follows: